SEMI® IMSG - Liaison Report - Japan



July 2004

SEMICON West 2004



Good news in Japan

- Welcome Prof. Kimata-san
 - Prof. Kimata-san joins IMSG Executive
 Committee as a program committee chair
- Congratulation Kaminaga-san
 - Kaminga-san assumes the presidency at xxxxx



Seminar Plan

- 6th Micromachine Seminar
 - Jun. 16th 2004 at Osaka
 - Chair: Prof. Susumu Sugiyama (Ritsumeikan Univ.)
 - Thema "PowerMEMS"
 - 110 Attendes
- 8th Microsystem/MEMS Seminar
 - Dec. 2nd 2004 at Makuhari
 - Chair:Prof. Masayoshi Esashi (Tohoku Univ.)



Support for MEMS industry activity

- Workshop at SEMI conference room
 - MSOL SeminarFebruary
 - VANS Seminar....July
 - BSACAugust
- Sponsorship/cooperation
 - PowerMEMS 2004



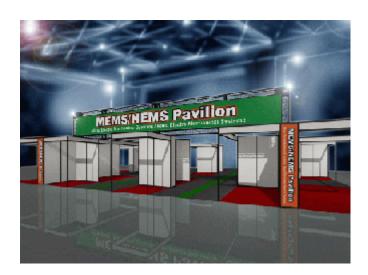
SEMICON Japan 2004 MEMS/NEMS Pavilion

Exhibit space application have been sent out

at the end of April.

Target >50 booths

- Three size of booth.
- MEMS Application showcase
- Academia Exhibit
- MEMS Exhibitor's Presentation Room





Exhibitors List as of July 9

- ACSES Co., Ltd.
- ASAHI TECHNO GLASS Corp.
- EV Group Japan K.K.
- ITOCHU MECHATRONICS Corp.
- Ushio Inc.
- NTT Advanced Technology Corp.
- KAYAKU MICROCHEM
- Kyodo International Inc.
- KST World Corp.
- SANYU ELECTRON CO., Ltd.
- Seki Technotron Corp.
- TDC Corp.

- Techscience Ltd.
- Tokuyama Corp.
- Toyota Tsusho Corp.
- Nihon Veeco K.K.
- JAPAN MEMS Co.,Ltd.
- JAPAN LASER CORP.
- Marubeni Solutions Corp.
- Universal Systems Co., Ltd.
- Tohoku University
- Nagoya University
- Ritsumeikan University
- National Metrology Institute of Japan
- Tokyo Institute sem r
 Technology

Major MEMS/Nano Event in Japan besides SEMI

- nano tech 2004 Mar. 17 19
- Sensor Expo Japan Apr.7 9
- APCOT Jul. 4 7
- Nanotech Business Fair Sept. 29 Oct. 1
- Sensor Symposium on Sensors, Micromachines, and Applied Systems Oct. 14 – 15
- PowerMEMS 2004 Nov.29 30
- MICROMACHINE 2004 Nov. 10 12

